

**Amendments to the Specification**

Please amend page 1, after the title and before paragraph [0001] as follows.

**UNITED STATES PATENT APPLICATION  
FOR  
METHOD AND APPARATUS FOR IMPROVING SILICON PROCESSING  
EFFICIENCY**

Having the inventors:

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who are all citizens of the United States of America.

**CROSS REFERENCE TO RELATED APPLICATIONS**

[0001] This application is a divisional of United States Patent Application Serial No. 10/227,362, filed on 22 August 2002. This application claims priority to United States Patent Application Serial No. 10/227,362 under 35 U.S.C. §120.